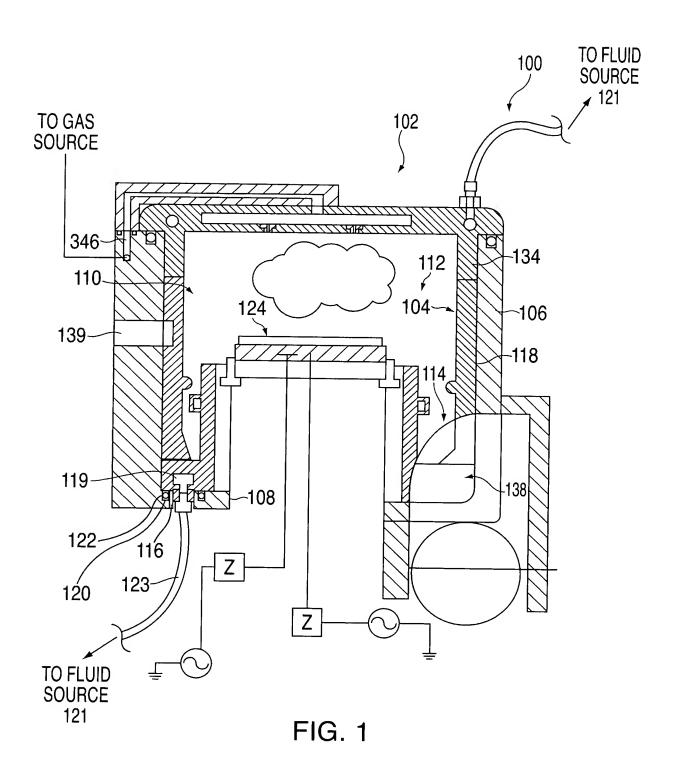


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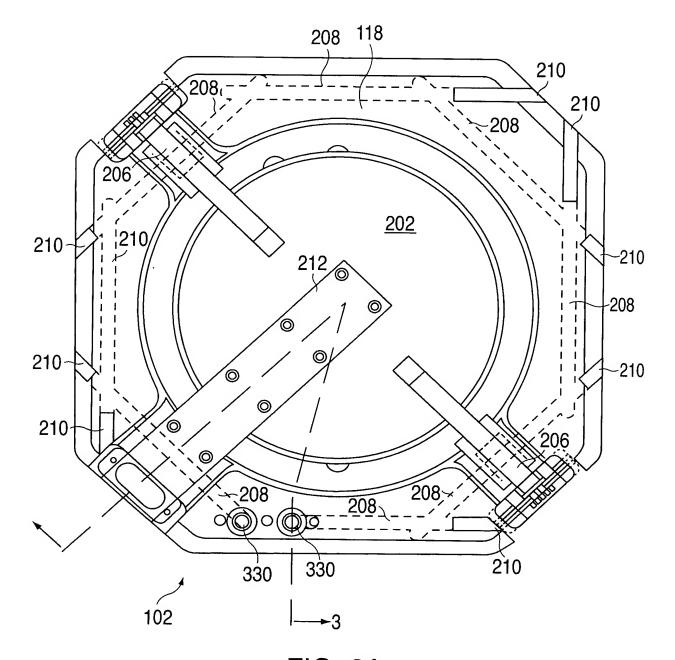


FIG. 2A



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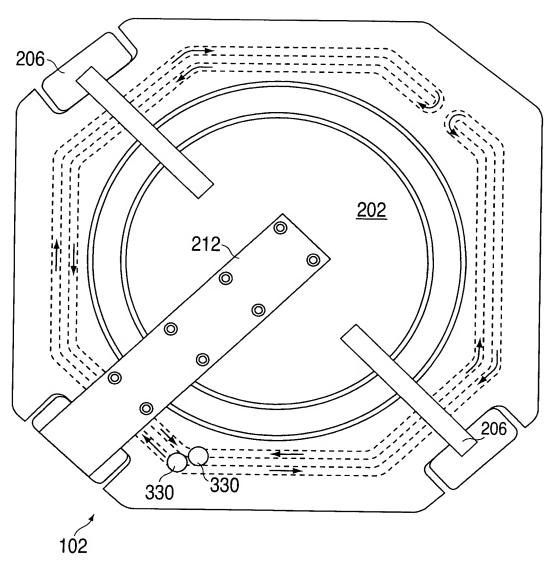
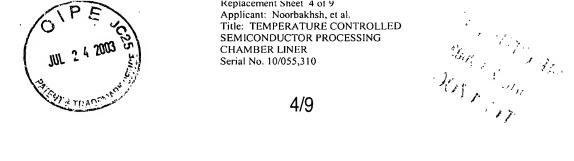
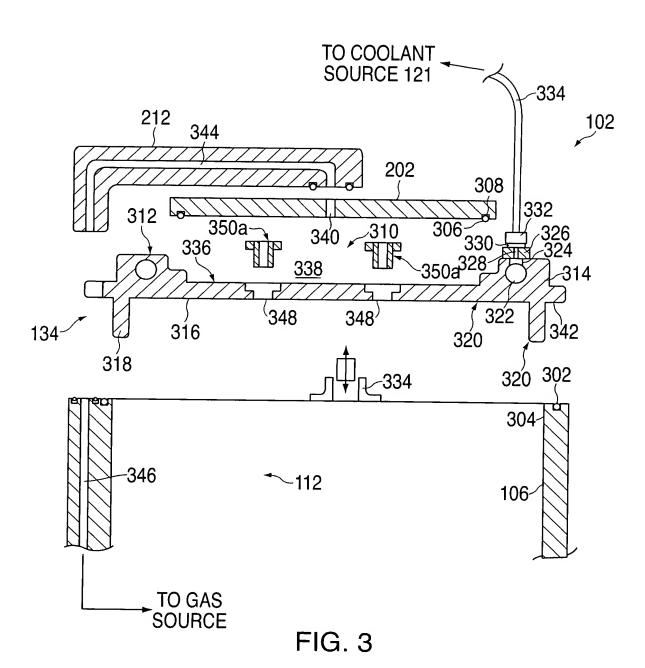


FIG. 2B







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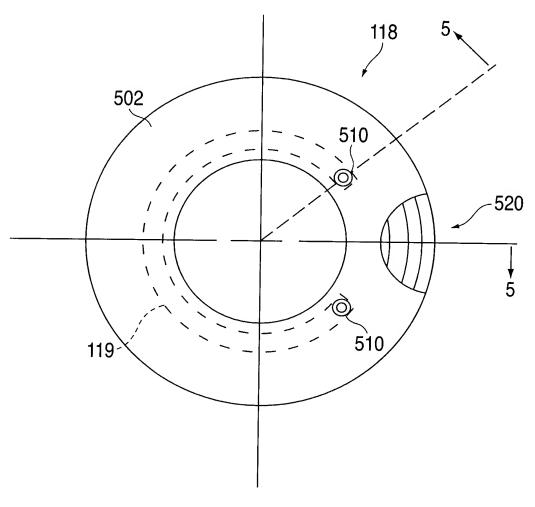


FIG. 4

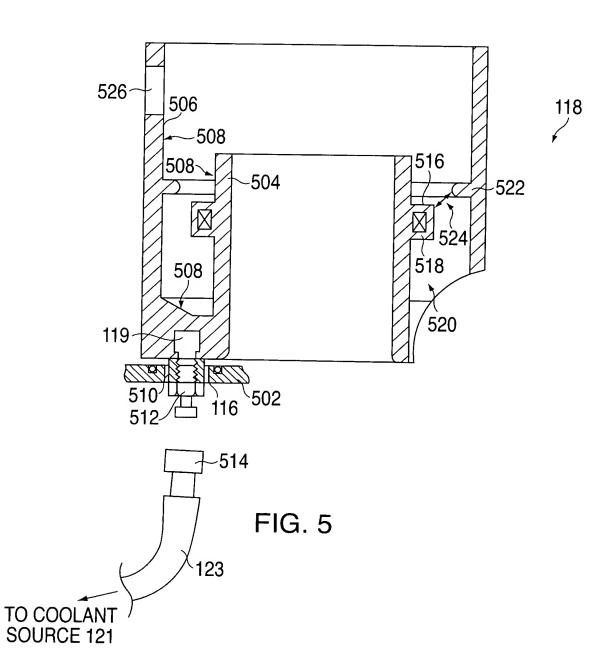


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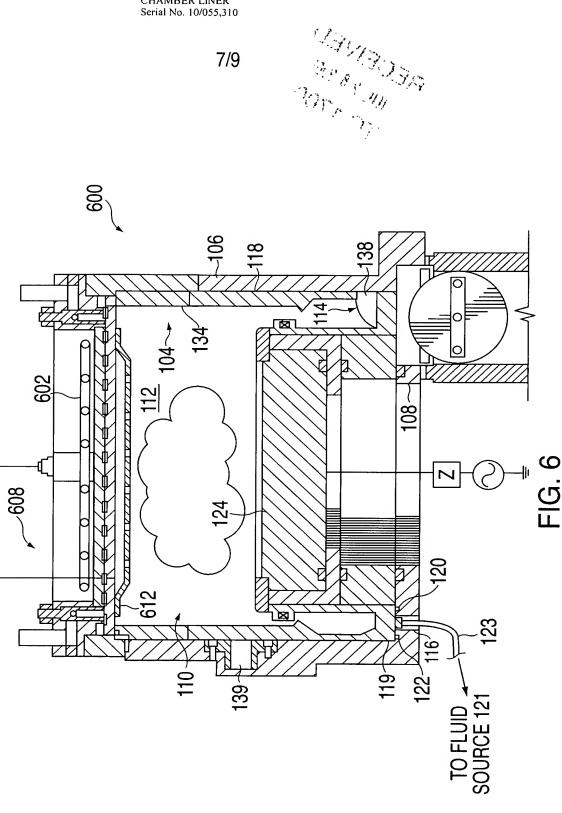
Mary Mary





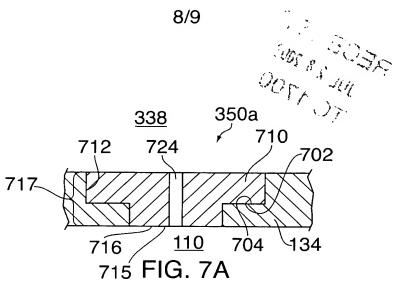
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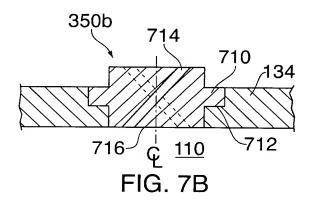
Replacement Sheet 7 of 9 Applicant: Noorbakhsh, et al.
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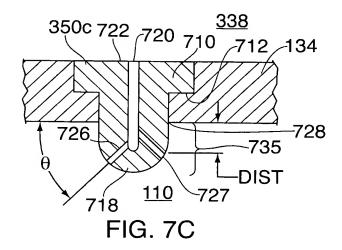




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